



Attorney Docket No. 0756-2409

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 2818
Koichiro TANAKA) Examiner: D. Le
Serial No. 10/021,719)
Filed: December 19, 2001)
For: LASER ANNEALING METHOD AND)
SEMICONDUCTOR DEVICE)
FABRICATING METHOD)
Please enter this paper by 11/4/05

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 29, 2005

Adrian M. Stamps

REVISED SUPPLEMENTAL AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 13 of this paper.